

U.S. UTILITY Patent Application

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PATENT DATE

APPLICATION NO.
09/708085

CONT/PRIOR
F

CLASS
427

SUBCLASS

ART UNIT
2813

EXAMINER

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TITLE
Method for fabricating semiconductor device

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DRAWINGS

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NOTICE OF ACTION REQUIRED

ISSUE FEE

Amount Due

Amount Paid

ISSUE BATCH NUMBER

☐ The term of this patent shall be extended beyond the expiration date of the patent.

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